

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Xiaolei Shi et al.  
Appl. No.: 10/814,697  
Filed: 30 March 2004  
Conf. No.: 7228  
Art Unit: 1795  
Examiner: Anna L. Verderame  
Docket No.: 140264-1  
Title: NEAR FIELD OPTICAL STORAGE MASK LAYER, DISK, AND  
FABRICATION METHOD

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION OF 2 OCTOBER 2008**

In response to the Office communication dated 2 October 2008, please consider the following Remarks.

**Listing of Claims** begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.